

L Number	Hits	Search Text	DB	Time stamp
1	299752	spacer	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 09:51
2	1488752	seal\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 09:51
3	10358	reflective near5 substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 09:52
4	13308	cross-over	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 09:52
5	41	spacer same seal\$3 same (reflective near5 substrate)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 09:52
6	1	cross-over same (spacer same seal\$3 same (reflective near5 substrate))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 09:52
7	29285	349\$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 09:52
8	18	(spacer same seal\$3 same (reflective near5 substrate)) and 349\$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:00
9	1468876	communicat\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:00
10	306	cross-over near10 communicat\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:00
11	2	349\$.ccls. and (cross-over near10 communicat\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:00
12	143	cross-over and 349\$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:01
13	2	(reflective near5 substrate) same cross-over	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:01
14	1520630	substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:01

15	785820	adhesive	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:01
16	204	cross-over near10 substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:02
17	288285	liquid adj crystal	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:02
20	1	349\$.ccls. and (adhesive near10 communicat\$3 near10 substrate)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:03
21	1	(adhesive near10 communicat\$3 near10 substrate) same (liquid adj crystal)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:03
19	48	(cross-over near10 substrate) and (liquid adj crystal)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:05
22	1	("6476415").PN.	USPAT; US-PGPUB	2003/02/06 10:05
18	131	adhesive near10 communicat\$3 near10 substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:31
23	0	(cross-over near10 communicat\$3) near10 substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:32
24	16	(cross-over near10 communicat\$3) same substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 10:33
25	1	jp-56085731-\$.did.	JPO	2003/02/06 11:04
26	0	"6259501"	JPO	2003/02/06 11:00
27	1	"6259501"	USPAT	2003/02/06 11:00
28	10	("3932026" "4868616" "5281450" "5576070" "5583675" "5623353" "5625473" "5644415" "5905548" "5978064").PN.	USPAT	2003/02/06 11:00
29	100	oguchi-koichi.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:04
30	0	cross-over and oguchi-koichi.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:04
31	45	(liquid adj crystal) and oguchi-koichi.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:12

32	1	communicat\$3 and oguchi-koichi.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:13
33	4	silvergold	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:13
34	5	(silver gold) near10 (electrical adj path) near10 substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:21
36	3	349\$.ccls. and ((silver gold) same (electrical adj path) same substrate)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:25
37	4	(liquid adj crystal) same ((silver gold) same (electrical adj path) same substrate)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:25
35	98	(silver gold) same (electrical adj path) same substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:42
38	43810	conductive near5 coating	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:42
39	89801	patternin\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:42
40	178	(conductive near5 coating) near10 patternin\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:43
41	57	((conductive near5 coating) near10 patternin\$3) near10 substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:43
42	8	349\$.ccls. and (((conductive near5 coating) near10 patternin\$3) near10 substrate)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:45
43	44771	bladder	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:45
44	11009	mechanical adj press\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:46
45	30470	shim	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:46

46	2	bladder same (mechanical adj press\$3) same shim	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:46
47	54	bladder same (mechanical adj press\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:46
48	6	(bladder same (mechanical adj press\$3)) same substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:47
49	5	vacuum near10 bag near10 align\$3 near10 substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:50
50	18	vacuum same bag same align\$3 same substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:50
51	13	(vacuum same bag same align\$3 same substrate) not (vacuum near10 bag near10 align\$3 near10 substrate)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/02/06 11:50